

13 Rec'd PCT/PTO 26 FEB 2002

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Yasunori UENO

Application No.: US National Stage of
PCT/JP01/09431

Filed: February 26, 2002

Docket No.: 112064

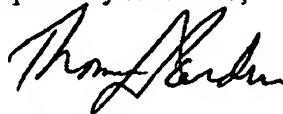
For: SPECTACLE LENS MANUFACTURING METHOD AND SPECTACLE LENS
SUPPLY SYSTEMREQUEST FOR APPROVAL OF DRAWING CORRECTIONDirector of the U.S. Patent and Trademark Office
Washington, D.C. 20231

Sir:

The Examiner is requested to review and approve the proposed correction to
Figure 25, marked in red on the attached copy of such drawing figure.

Upon approval by the Examiner, and upon allowance of this application, the formal
drawings will be corrected.

Respectfully submitted,

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Date: February 26, 2002

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Hayes

FIG.25

left

AFTER REDESIGN

	+3D(μm)
FIRST SURFACE RADIUS OF CURVATURE (mm)	92.242*
SECOND SURFACE RADIUS OF CURVATURE (mm)	200.000
CENTER THICKNESS (mm)	4.0
LENS DIAMETER (mm)	6.5
EDGE THICKNESS (mm)	1.0
OVERALL HEIGHT (mm)	6.7

* : ASPHERICAL SURFACE